



# 16th International Conference on Atomically Controlled Surfaces, Interfaces and Nanostructures (ACSIN-16)

## 34th International Colloquium on Scanning Probe Microscopy (ICSPM34)



Oct. 19-23, 2026

Arcrea HIMEJI, Himeji city, Hyogo, Japan

### Sessions of Conference

- Surface Characterization, Methods and Instruments
- Scanning Probe Microscopy
- Fabrication of Nanostructures and Films
- Surface and Interface Engineering for Electronic Devices
- Electrons, Spins, Photons, Phonons in 1D, 2D Materials
- Soft Materials: Synthetic and Biological
- Surfaces under Vacuum, Vapor, Plasma
- Interfaces Buried in Liquid, Solid

### Symposia

- Machine Learning for Atomical Control
- Quantum Beams for Atomical Control
- Atomically Controlled Materials for Carbon Neutrality
- Atomically Controlled Materials for Quantum Applications

### Conference Chairs

- Organizing: H. Watanabe (The Univ. of Osaka)
- Steering: M. Yoshimura (Toyota Tech. Inst.)  
K. Sumitomo (Univ. of Hyogo)
- Program: H. Onishi (Kobe Univ.)



### Registration fee

- Abstract Deadline : June 22, 2026**
- Acceptance Notice : July 21, 2026**
- Advanced Registration : September 7, 2026**
- Proceedings Deadline : November 30, 2026**

	Early Bird By September 7, 2026	General From September 8, 2026
Regular	65,000 JPY	75,000 JPY
Student	25,000 JPY	30,000 JPY